



Am

PATENT
Customer No. 22,852
Attorney Docket No. 04329.3100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Kei HAYASAKI et al.) Group Art Unit: 1756
Application No.: 10/624,593) Examiner: Barreca, Nicole M.
Filed: July 23, 2003) Confirmation No. 7500
For: METHOD FOR FORMING A)
PATTERN AND SUBSTRATE-)
PROCESSING APPARATUS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

In the Restriction Requirement mailed June 17, 2005, with a period for response extending to July 17, 2005, the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 1-48), Group II (claims 49-84), and Group III (claims 85-125). Applicants elect to prosecute Group I, claims 1-48, characterized by the Examiner as drawn to a pattern forming method, without traverse.

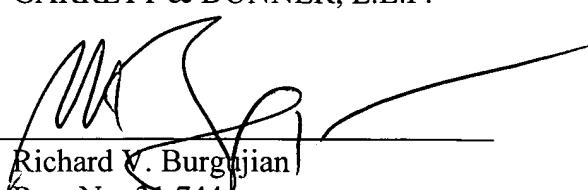
Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: July 13, 2005

By:


Richard V. Burguijan
Reg. No. 31,744